

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	§	
Chung-Chieh Fang	§	Group Art Unit: Unknown
	§	
Serial No. Unknown	§	
	§	Examiner: Unknown
Filed: Herewith	§	
	§	
For: Semiconductor Manufacturing	§	
Capacity Features Exchange System		

INFORMATION DISCLOSURE STATEMENT

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists. The cited patents are listed in numerical order and are not in any order based on their pertinence.

The above-identified application is being filed after June 30, 2003. Therefore, pursuant to the waiver of the requirement under 37 CFR 1.98 (a)(2)(i) as stated in a Pre-OG Notice dated July 11, 2003, copies of only the foreign patent documents and non-patent literature listed on the enclosed modified Form PTO-1449 are attached.

This Information Disclosure Statement is being filed within three months of the United States filing date or before the mailing date of a first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)).

The Commissioner is hereby authorized to charge any additional fees which may be required or credit any overpayment to Deposit Account 08-1394.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,



David M. O'Dell
Registration No. 42,044

Date: 3-26-04
HAYNES AND BOONE, LLP
901 Main Street, Suite 3100
Dallas, Texas 75202-3789
Telephone: 972-739-8635
Facsimile: 214-200-0853
File: 24061.106

R-70630.1

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on March 26, 2004

Bonnie Boyle

Printed Name

Bonnie Boyle

Signature

In place of PTO-1449 Form		U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	
				Filing Date	Herewith
				Applicant(s)	
				Art Unit	
				Examiner Name	
SHEET	1	OF	1	Attorney Docket Number	24061.106 (TSMC2003-0551)

U. S. PATENT DOCUMENTS				
Examiner's Initials	Cite No.	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
	AA	6,321,212	11-20-2001	Lange
	AB	2003/0125982	07-03-2003	Ginsberg et al.
	AC	2003/0126062	07-03-2003	Gilbert et al.
	AD	6,594,643	07-15-2003	Freeny, Jr.
	AE	2003/0135441	07-17-2003	Ginsberg
	AF	6,598,028	07-22-2003	Sullivan et al.
	AG	2003/0139995	07-24-2003	Farley

FOREIGN PATENT DOCUMENTS					
Examiner's Initials	Cite No.	Foreign Patent Document (Country Code - Number - Kind)	Publication Date MM-DD-YYYY	Patentee or Applicant of Cited Document	Translation Y/N

OTHER PRIOR ART		
Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume- issue number(s), publisher, city/country where published
	AH	"Virtual Fab Services - iFAB", Advanced Semiconductor Manufacturing Corp. of Shanghai, December 31, 2003, 2 pgs.
	AI	"About Virtual Fab Corporation", Virtual Fab Corporation, December 31, 2003, 2 pgs.
	AJ	CRISTA SOUZA, "DRAM Futures Trading Stages A Comeback", July 28, 2003, 5 pgs., EE Times UK
	AK	"One-on-One with TSMC Chairman Morris Chang", December 4, 1998, 3 pgs., ebn News
	AL	WILLIAM WANG, "TSMC eFoundry Suite of Services Offers Customers Unprecedented Transparency in the Manufacturing Process", Future Fab International, June 29, 2003, 6 pgs., Volume 11, Future Fab, Intl.

Examiner Signature		Date Considered	
--------------------	--	-----------------	--

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.